



#22(Amd+ PATENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

UNO et al.

Examiner:

M. ANGEBRANNDT

Serial No.:

09/390,228

Group Art Unit:

1756

Filed:

SEPTEMBER 3, 1999

Docket No.:

10873.274USI1

Title:

OPTICAL INFORMATION RECORDING MEDIUM, PRODUCING

METHOD THEREOF AND METHOD OF RECORDING/ERASING/

REPRODUCING INFORMATION

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# AMENDMENT UNDER 37 C.F.R § 1.111

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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Dear Sir:

In response to the Office Action dated March 6, 2003, Applicants provide the following amendments and remarks.

## In the Specification

Please replace the paragraph beginning on page 70, line 28 and ending on page 71, line 8 with the following new paragraph.

-When forming the diffusion preventing layers 67 and 68, there was no difference between samples 100 to 109 as to the sputtering gas, which was a mixed gas comprising Ar and nitrogen, a sputtering gas pressure of 10 mTorr, and a sputtering power density of 6.37 W/cm<sup>2</sup>. When forming the diffusion preventing layer 67, the partial pressure of nitrogen in the sputtering gas was constantly 40 % (40 vol % nitrogen). When forming the diffusion preventing layer 68, the partial pressure of nitrogen in the sputtering gas was changed to 10%, 20%, 30% and 40%. In this case, the content of nitrogen contained in the diffusion preventing layer 67 was 56 atom %

